



Lessons Learned with Spark at the US Patent & Trademark Office

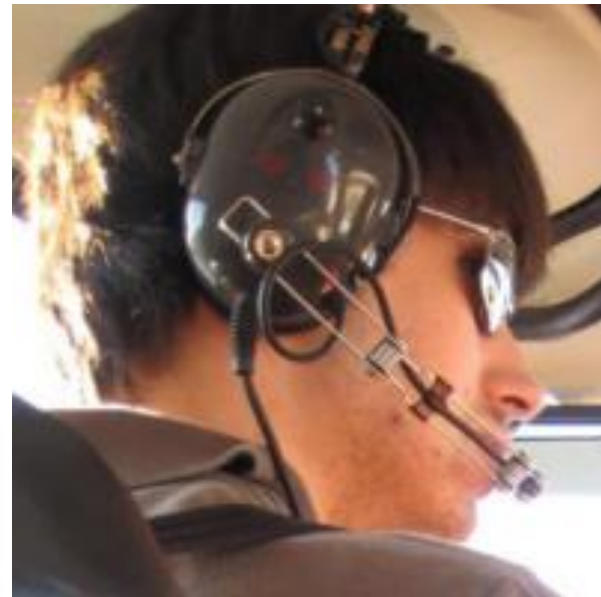
Christopher Bradford

Big Data Architect at OpenSource Connections

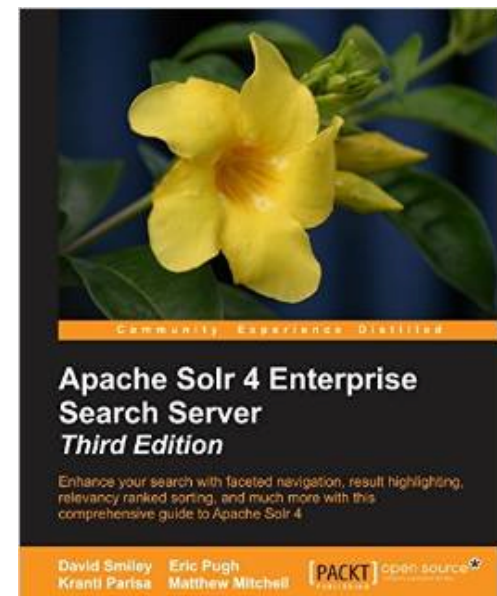
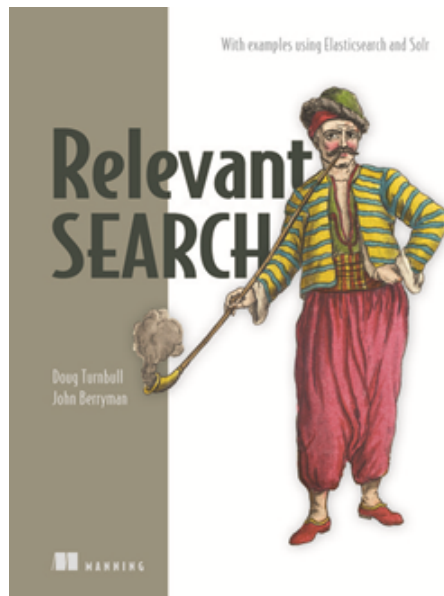
Christopher Bradford

Twitter: @bradfordcp

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OpenSource Connections



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977 results found. Currently displaying results 1-100. Page 1 of 10

DATE	US	NO	CLASS	INVENTOR	TYPE
2001-04-05	US-20010000091-A1	1	Method of operating a combustion turbine		
2001-04-05	US-20010000092-A1	1	Locking swivel wrench		
2001-04-05	US-20010000093-A1	1	Silicon single crystal wafer and a method		
2001-04-05	US-20010000094-A1	1	Exhaust heat recovery boiler		
2001-04-05	US-20010000095-A1	1	Method and device for regulating the out		
2001-04-05	US-20010000096-A1	1	Tape dispenser		
2001-04-05	US-20010000097-A1	1	Anti-static, anti-corrosion, and/or anti-m		
2001-04-05	US-20010000098-A1	1	Equipment for UV wafer heating and ph		
2001-04-05	US-20010000099-A1	1	Snubbing unit tong apparatus		
2001-04-05	US-20010000100-A1	1	Method for mounting devices on a print		
2001-04-05	US-20010000101-A1	1	Reinforced abrasive-impregnated cutting		

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Silicon Single Crystal Wafer And A Method For Producing It

NUMBER	DATE PUBLISHED	CLASS	INVENTOR	TYPE
20010000093	2001-04-05	117/13	Sakurada, Masahiro et al.	Patent

Abstract

There is disclosed a method for producing a silicon single crystal in accordance with the Czochralski method wherein a crystal is pulled with controlling a temperature in a furnace so that .DELTA.G may be 0 or a negative value, where .DELTA.G is a difference between the temperature gradient Gc (.degree. C./mm) at the center of a crystal and the temperature gradient Ge (.degree. C./mm) at the circumferential portion of the crystal, namely .DELTA.G=(Ge-Gc), wherein G is a temperature gradient in the vicinity of a solid-liquid interface of a crystal from the melting point of silicon to 1400.degree. C., and with controlling a pulling rate in a range between a pulling rate corresponding to a minimum value of the inner line of OSF region and a pulling rate corresponding to a minimum value of the outer line, when OSF region is generated in an inverted M belt shape in a defect distribution chart which shows a defect distribution in which the horizontal axis represents a diameter of the crystal and the vertical axis represent a pulling rate. There can be provided a method of producing a silicon single crystal wafer by CZ method wherein OSF in the ring shape



EST – Technology Stack

DATASTAX 

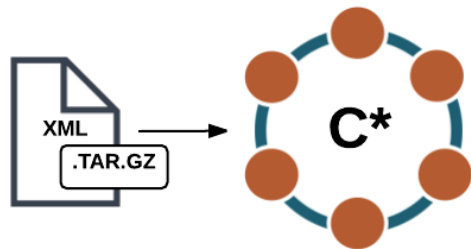
 **Cassandra**

Solr 

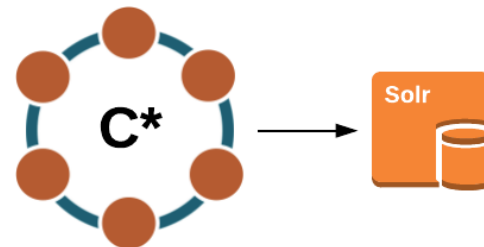


EST – Data Loading

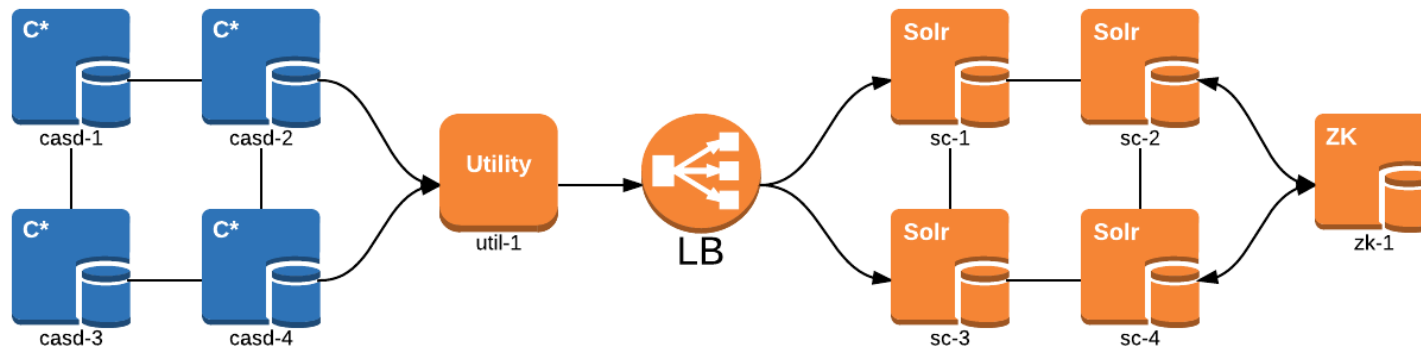
CSS Ingestion (CSS2C)



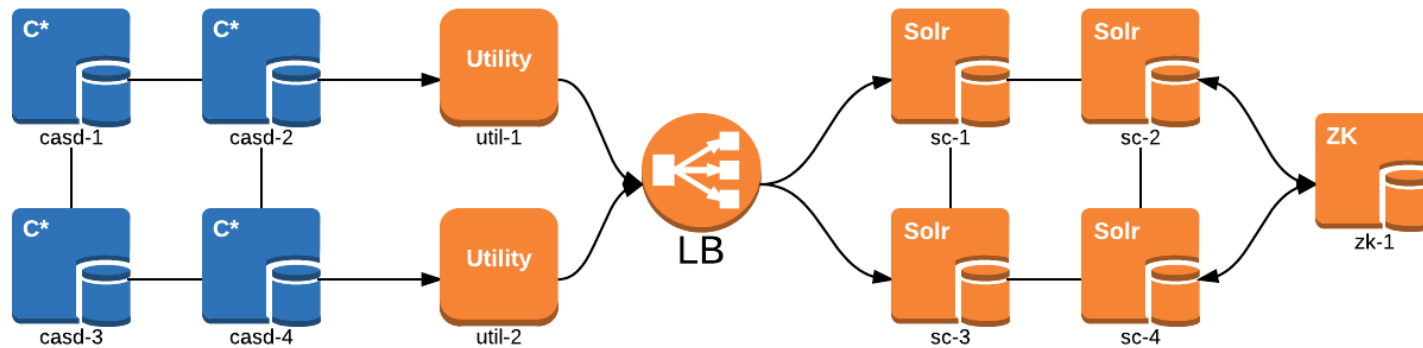
Solr Ingestion (C2S)



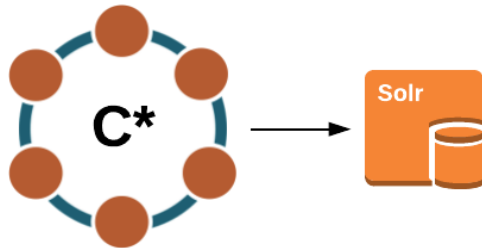
EST – C2S Process



EST – C2S Process (Scaled Out)



EST – C2S Review



Did it work?

Why change it?

How could we make it better?



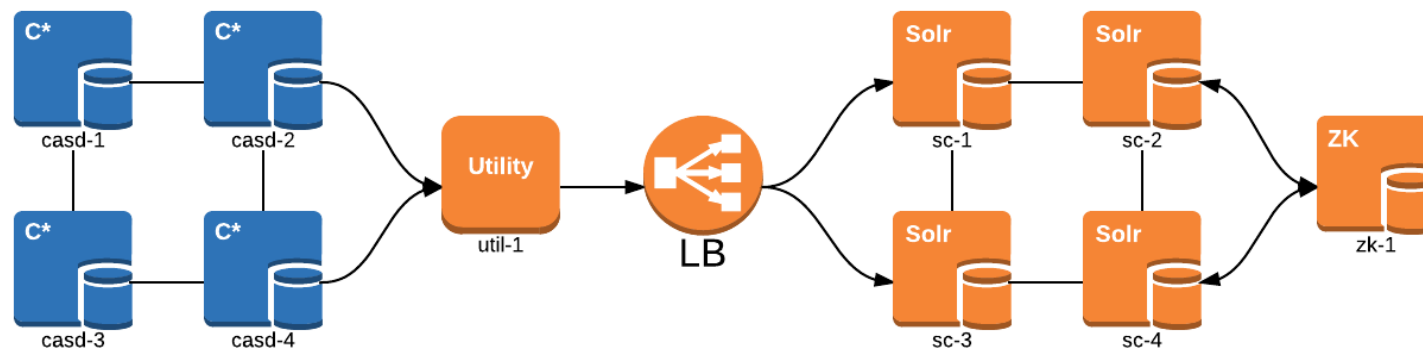
Spark

A large, stylized orange star with a white center, positioned behind the end of the word "Spark".

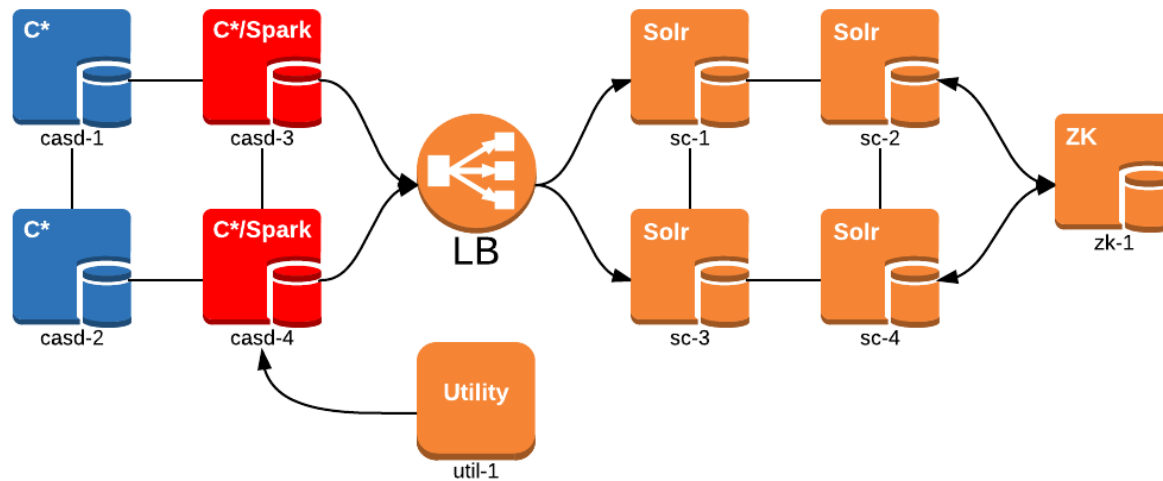
Spark
summit 2015



EST – Old C2S Process



EST – Spark C2S Process



How did this work out?

Poorly



Poor Performance

```
joinedRDD = ...  
joinedRDD.foreach()  
    document = ... // build document  
    sc = new SolrConnection()  
    sc.push(document)  
    sc.disconnect()  
// Job is done
```



Poor Performance

```
sc = new SolrConnection()  
sc.push(document)  
sc.disconnect()
```



Optimum Performance

```
joinedRDD = ...  
sc = new SolrConnection()  
joinedRDD.foreach()  
    document = ... // build document  
    sc.push(document)  
sc.disconnect()  
// Job is done
```

```
joinedRDD = ...  
joinedRDD.foreachPartition()  
    sc = new SolrConnection()  
    partition.foreach()  
        document = ... // build document  
        sc.push(document)  
    sc.disconnect()  
// Job is done
```

Almost



The Solution!

```
joinedRDD = ...  
joinedRDD.mapPartitions()  
    sc = new SolrConnection()  
    partition.foreach()  
        document = ... // build  
document  
    sc.push(document)  
    sc.close()  
    return partition.rows  
.collect()
```

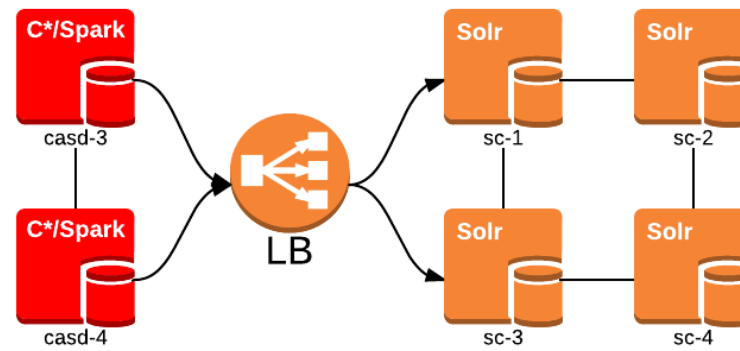
```
joinedRDD = ...  
joinedRDD.mapPartitions()  
    sc = new SolrConnection()  
    partition.foreach()  
        document = ... // build  
document  
    sc.push(document)  
    sc.close()  
    return partitions.rows.count  
.collect()
```



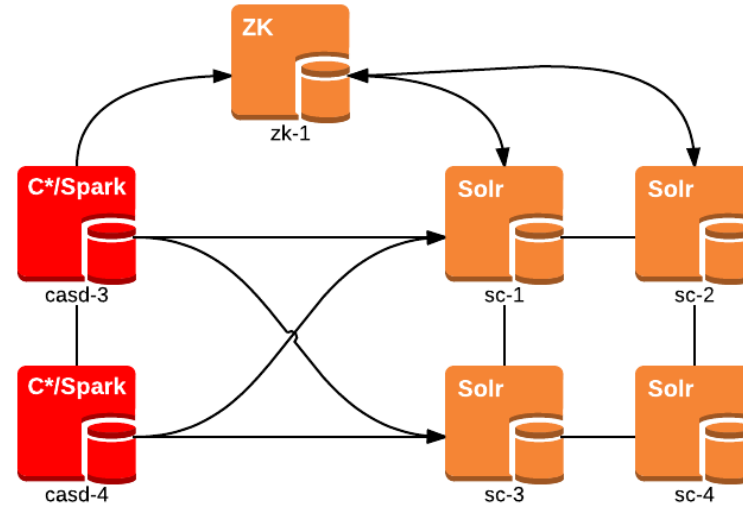
Results?



Solr Indexing

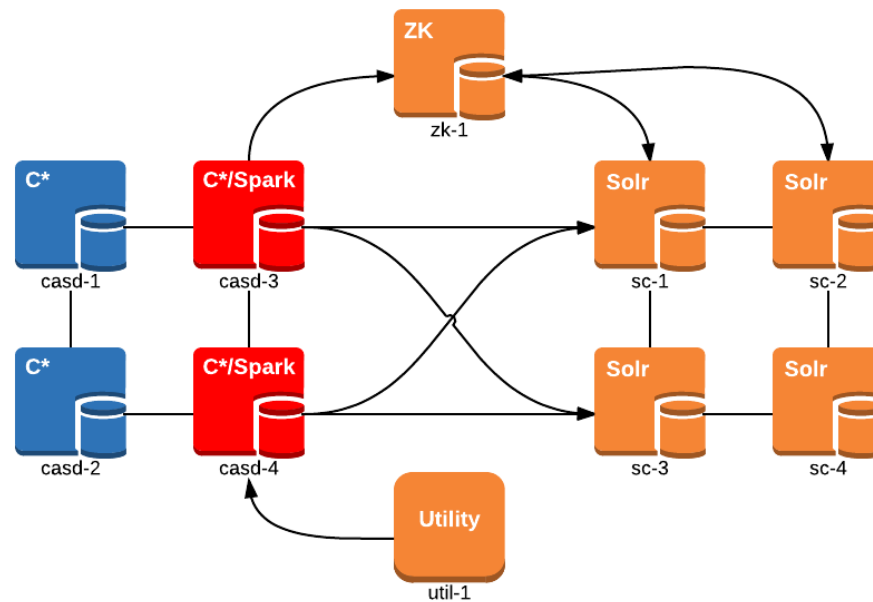


Better Solr Indexing



Note: some connections are omitted for clarity

EST – Spark C2S Process v2



Note: some connections are omitted for clarity

Success?

YUP

5x faster than the original C2S process (with optimizations)



What's Next?

- Optimization of the C2S Spark job
- More Spark jobs
- Newer version of Spark & DSE
- Scala Spark jobs instead of Java

